



JSW

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Commissioner for Patents
P.O. Box 1450
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PATENT
Attorney Docket No.: 18062L-006400

On 12/22/04

TOWNSEND and TOWNSEND and CREW LLP

By: *Linda Shaffer*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Di Gao et al.

Application No.: 10/613,508

Filed: July 3, 2003

For: SELECTIVE ETCHING OF
SILICON CARBIDE FILMS

Customer No.: 20350

Confirmation No.: 4814

Examiner: David E. Graybill

Technology Center/Art Unit: 2822

RESPONSE TO RESTRICTION
REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

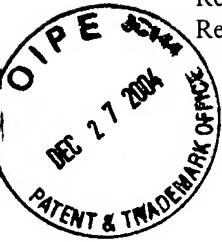
Sir:

In response to the Restriction Requirement mailed November 26, 2004,
Applicants elect to prosecute the claims of Group I, claims 1-25 and 31-33, drawn to a process.

The foregoing election is made with traverse. Examination of the subject matter recited in the claims of Groups I-II would not place a substantially greater burden on the Examiner. Accordingly, Applicants respectfully request the Examiner to withdraw the Restriction Requirement and to consider claims 1-33 together in the present case.

Appl. No. 10/214,631
Response dated December 21, 2004
Reply to Rest. Req. of November 26, 2004

PATENT



CONCLUSION

If the Examiner believes a telephone conference would expedite prosecution of this application, please telephone the undersigned at 925-472-5000.

Respectfully submitted,

Babak Kusha

Babak Kusha
Reg. No. 51,095

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